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CONFIRMATION NO. 2722

SERIAL NUMBER 10/587,039	FILING OR 371(c) DATE 07/24/2006 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 061063-0356139
APPLICANTS Masataka Hourai, Saga-shi, JAPAN; Wataru Sugimura, Saga-shi, JAPAN; Toshiaki Ono, Saga-shi, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP05/15346 08/24/2005				
** FOREIGN APPLICATIONS ***** JAPAN 2004-246017 08/25/2004 JAPAN 2005-163152 06/02/2005 JAPAN 2005-239529 08/22/2005				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/02/2007				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>John Felt</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 8
INDEPENDENT CLAIMS 2				
ADDRESS 909				
TITLE Silicon wafer, method for manufacturing the same and method for growing silicon single crystals				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	